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An investigation using DFT into the impact of hydrogen on oxygen migration processes during aluminum anodization

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First-principles computations were utilized to examine the impact of H atoms on the surface behavior of O atoms on the (111) surface of Al and their infiltration behavior into the Al crystal, with the aim of elucidating the behavior of ions in the anodic process during aluminum oxidation. According to the findings, the “abstract” action of H atoms significantly lowers the energy barrier preventing O from entering the Al crystal. The addition of a H atom influences the diffusion of O atoms in the Al crystal as well, and this can lower the activation energy of O atom migration between the tetrahedral interstitial locations from 1.23 eV to 0.35 eV. We can benefit from knowing how ions are transported and anodic oxidation occurs.

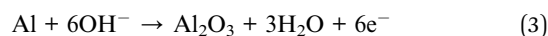
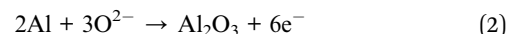
1. Introduction

Since the beginning of the 20th century, anodic aluminium oxide (AAO) has been widely used in industry for several applications, such as corrosion protection, colouring, and production of capacitors, due to its highly ordered arrangement, stable physical and chemical properties, and low cost.^{1,2} The electrochemical method for producing aluminum oxide thin films was first proposed by Keller *et al.* in 1953. However, it is labor-intensive, time-consuming, and has a low repetition rate.³ AAO was prepared using a two-step anodic oxidation approach by Masuda *et al.* in 1995.⁴ Due to its excellent reproducibility and stable pore formation, this approach gained recognition in academia.

In order to understand the growth mechanism of the porous layers during anodizing, several experimental studies⁵ have investigated the effect of the anodizing conditions, especially the chemical composition of the electrolyte, voltage or current density, on most structural parameters of AAO, such as nanopore diameter and wall thickness. Furthermore, several models, such as the field-assisted model,^{6,7} the stress-induced plastic flow model,^{8,9} the volume expansion stress model^{10,11} and the oxygen bubble mold model,^{12–14} were proposed to elaborate the growth mechanism of the porous layers during anodizing. Although these theories are different, they are all based on a common cognition: the formation of AAO is a competition between the two reactions of aluminium oxidation and alumina dissolution. AAO grows stably when the reaction rates of these two reactions are in equilibrium. Fig. 1 shows that the

electrochemical reactions and ion paths occur during the anodizing of aluminium. For electrode reactions, the following reaction equation is generally accepted in academia:¹⁵

Anode:



Cathode:



Total:

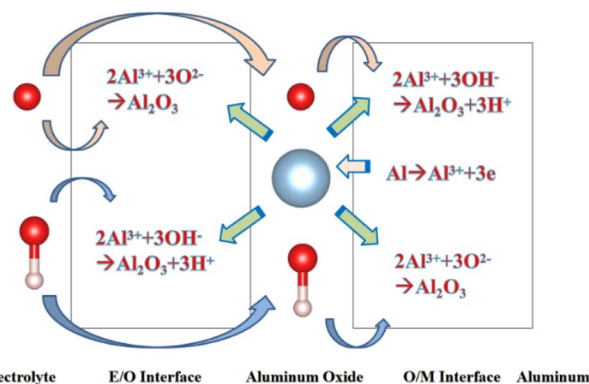
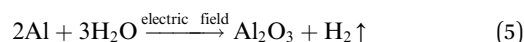


Fig. 1 Schematic diagram showing the electrochemical reactions and ionic paths occurring during aluminium anodizing.

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The rate of growth of anodic films during anodization under mild experimental conditions is limited by the solid-state transport of ions within the oxide layer formed on the anode.² Several models, such as Cabrera and Mott's model,^{16,17} Verwey's model,¹⁸ Dewald's model,^{19,20} point defect model (PDM)^{21–25} and Lohrengel's model²⁶ were proposed to explain the process of ionic functional group (OH⁻) transport. Those models all emphasize the important role of electric field strength E . Subsequent researchers obtained the following empirical equation from experience:^{27,28}

$$j = j_0 \exp(\beta E) = j_0 \exp\left(\beta \frac{\Delta U}{t_B}\right) \quad (6)$$

where j is ionic current density, represents the velocity of ions transport, j_0 and β are material dependent constants at a given temperature, ΔU is the potential drop in the oxide layer and t_B is a thickness of the oxide layer.

The eqn (6) empirically explains the relationship between field strength and ion migration rate. This equation is reliable when the process occurs in the alumina solid state, because of the migration of vacancies inside the alumina under the action of an electric field. Existing study had got the result of the migration and activation energy of O atoms on the surface of aluminum, which the energy is large and ion diffusion is difficult.²⁹

Density functional theory (DFT) has been the most effective tool in condensed matter physics for computing electronic structure and its properties since its inception in the 1960s, when it was initially used to derive the well-known Kohn–Sham (KS) equation under the local density approximation (LDA). Numerous atomic and molecular physics puzzles, including those involving catalytic active sites,^{30,31} geometric structure,^{32,33} and material electronic structure properties,^{34,35} can be resolved with DFT. DFT is also commonly used to calculate the functions of the ions during chemical reactions,^{36,37} as it can accurately reveal reaction pathways clearly.

In this study, the first-principles calculations were used to compare the migration and diffusion behaviours of O atom and O–H group on the surface of aluminum and inside the crystal of aluminum. Thus, we also discuss the role of H, the smaller atom, in the process of aluminium anodizing.

2. Calculation method and details

The Vienna *ab initio* simulation package (VASP),³⁸ which is based on the pseudopotential plane wave approach and density functional theory, was used to conduct the simulations. The electron projector-augmented wave method³⁹ was used to predict the interactions between ions and valence electrons. The Perdew–Burke–Ernzerhof generalized gradient approximation⁴⁰ was used to determine the exchange–correlation function. The conjugate gradient method⁴¹ was used to optimize the geometric structure of the model. The electronic occupancy was determined using the Methfessel–Paxton method,⁴² in which the smearing width was 0.05 eV. Self-consistent iterative matrix diagonalization uses the residual minimization scheme-direct inversion in the iterative subspace (RMM–DIIS) algorithm.⁴³

All self-consistent loops were iterated until the total energy difference among the systems, which was measured between the adjacent iterating steps reached less than 1×10^{-5} eV. The cutoff energy for the plane waves was 400 eV.

To investigate the role of smaller atom H during the oxidation of aluminium, surface and crystal models were established. The surface model contained 96 atoms distributed over 6 layers, in which the upper four layers were relaxed and the lower two layers were fixed. To avoid the effect of the periodic boundary conditions, a vacuum layer was set at more than 18 Å. In the top view, the slab of (111) surface of Al was built as a rhombic consisting of 4×4 primitive unit cells. As shown in the Fig. 2, there were three adsorption sites: face-centered cubic (Fcc), hexagonal closest packing (Hcp), and Top, which were located in the three-fold hollow site on the surface, in the other three-fold hollow site on surface as well as on the top of the sub-layer atoms, and on the top of the surface atoms, respectively. The crystal model contained 32 Al atoms and $2 \times 2 \times 2$ cubic unit cells. In the crystal model, all atoms were relaxed. There were two occupied positions: the octahedral interstitial (Oct) and the tetrahedral interstitial (Tet) positions. All the mentioned adsorption or doping positions refer to the occupation of the O atom, and the distance between O–H was initially set to 0.98 Å, based on the single bond distance between O atom and H atom.⁴⁴

When the O–H group is adsorbed on the surface of aluminum, due to the strong Al–O interaction, the distance between O–H will increase significantly, under the condition of the electric field does not play a leading role. After that, OH will dissociate on the surface of aluminum that is not completely ionized. Once the Al ionized completely, OH and the Al ions generate the ionic compound.^{45,46} Therefore the calculation in this paper adopts the O–H group and O atom. Even if charged ions were used, the adsorption structure and migration path of charged ions were the same, so the results and the conclusion

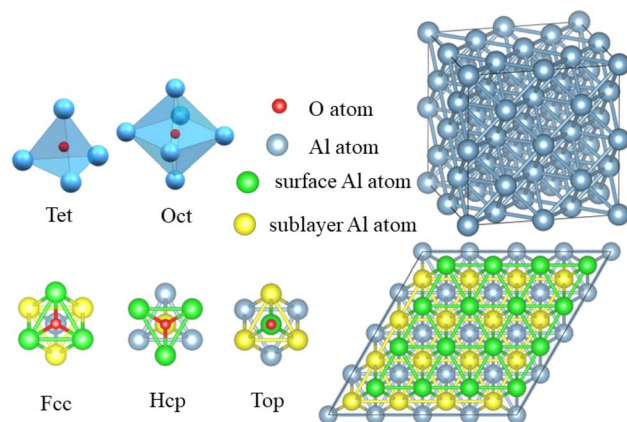


Fig. 2 Top view of the adsorption and occupied positions. There are three adsorption positions: Fcc, Hcp, and Top. In addition, two sub-layer jobs were occupied: Oct and Tet. The cyan ball represents an Al atom on the surface; the yellow ball represents an Al atom in the sublayer; the green ball represents an Al atom in the third layer; and the small red ball indicates an oxygen atom.

were all the same.⁴⁷ Therefore, the calculational results here are appropriate when things come down to the experiments. The Monkhorst–Pack method⁴⁸ was used to divide the Brillouin zone using $[5 \times 5 \times 1]$ and $[7 \times 7 \times 7]$ k -points for the surface and crystal models, respectively.

Adsorption energy (E_{ad}) and binding energy (E_{bd}) characterize the adsorption of the O atom and the connection model on the surface of aluminum and within the aluminum crystal, respectively, which are defined by eqn (7) and (8) as follows:

$$E_{\text{ad}} = E_{\text{surf}} + E_{\text{OH}} - E_{\text{tot}} \quad (7)$$

$$E_{\text{bd}} = E_{\text{Al}} + E_{\text{OH}} - E_{\text{tot}} \quad (8)$$

where E_{surf} is the energy of surface model of aluminum; E_{Al} is the energy of aluminum crystal model; E_{tot} is total energy of the adsorption or doping system; and E_{OH} is the O–H group energy.

According to the transition-state theory, the migration activation energy (E_{sp}) can be defined as the difference between the lowest energy and the saddle point (SP) energy on the migration path. The SP is the highest energy point on the migration path and the lowest energy point on the other directions. The migration path was investigated using the Nudged elastic band method⁴⁹ to map the minimum energy path between the initial and final systems. Five initial images were created by linear interpolation.

As is known to all, much of oxygen's chemistry is driven by electron spin. The spin of oxygen had been considered. However, when spin is turned on, the required computation time will triple, even when using only the original cell. Considering the computational cost, preliminary calculations were conducted on the process to determine whether it was necessary to incorporate spin. The calculation involves using an oxygen atom and an O–H group to adsorb on the surface of aluminum and comparing the difference in adsorption energy between using spin and not using spin. The results showed that there was no change in the energies of two adsorption models and two surface models, while the energy of the O atoms

decreased by 1.49 eV. As a result, the absorption energy decreased by 1.49 eV. These results suggest that the spin of the oxygen does not influence the energy of the models, except for its own energy. The same results were obtained when it comes to the O–H group, showed an energy decrease of 0.44 eV. Furthermore, the literature suggests that the barriers arise from the energetic cost of initiating abrupt charge transfer from the metal surface to the membrane, and there is no need to consider non-destructive surface hopping or spin selection rules to explain the barrier.⁵⁰ Therefore, all the calculations in this paper did not consider the spin of oxygen, except for the E_{ad} and the E_{bd} .

3. Results and discussion

3.1 Adsorption and migration processes on the surface of aluminum

Adsorption distance and energy are both important and foundational reaction mechanism properties. The adsorption distance of O atom and O–H group on the (111) surface of aluminum had been tested in two different lengths on the Top position, 1.856 Å and 1.969 Å, which are two different bond lengths in α -alumina. As shown in Table 1, the energies and the distances after calculation between different distances were almost same. The different of energy (ΔE) was only 0.0004 eV of the adsorption of O atom on the (111) surface of aluminum, and 0.0017 eV of the adsorption of O–H group on the (111) surface of aluminum. On the other hand, the different of distance (ΔD) was only 0.001 and 0.0003 for the adsorption of atom O and O–H group respectively. The ΔD of O–H in different lengths was also very small, which is 0.0006 Å. As a result, all the data above indicate that the adsorption distance of Al and O in two conditions (atom O and O–H group) should be 1.68 Å and 1.69 Å. And the distance of atom O and atom H should be 0.96 Å in the case of O–H group adsorption on (111) surface of aluminium.

The O atom's adsorption energies on the (111) surface of Al is displayed in Table 2. In comparison to the adsorption energy at

Table 1 The distance and energy in different Al–O bond lengths. All data are retained to four decimal places

	Case of length (Å)	Distance (Å)	Energy (eV)	ΔE (eV) (absolute value)	ΔD (Å) (absolute value)
Atom O	Al–O	1.856	–235.0523	0.0004	0.0010
		1.969	–235.0519		
O–H group	Al–O	1.856	–239.9108	0.0017	0.0003
		1.969	–239.9125		
	O–H	1.856	–239.9108		
		1.969	–239.9125		

Table 2 Adsorption and binding energies of the oxygen atom and the O–H group

		Fcc	Hcp	Top	Oct	Tet
Atom O	E_{tot} (eV)	–237.87	–237.57	–235.05	–126.72	–128.15
	E_{ad} or E_{bd} (eV)	6.82	6.56	3.97	5.51	6.91
O–H group	E_{tot} (eV)	–241.01	–240.73	–239.91	—	–130.92
	E_{ad} or E_{bd} (eV)	4.89	4.62	3.80	—	3.70

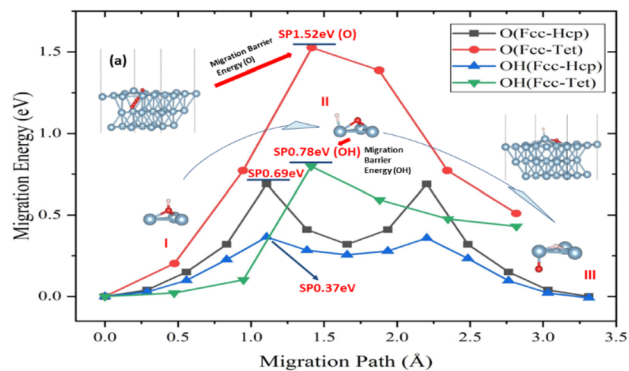


Fig. 3 Migration path and activation energy of O atom and O–H group on the (111) surface of Al. (a) Migration path of the O atom. (b) Dissociation structure of O–H group on the surface of aluminum. (I–III) Schematic of O–H group migration process.

the Hcp and Fcc positions, the Top position had a significantly lower level of stability. Given that the adsorption energies of the Hcp and the Fcc were comparable, but the Fcc position had the highest energy, the O atom should be adsorbed at the Fcc site. That results are similar with the literature reported before.⁵¹ However, things change a little bit after the H atom enters the migratory process. The migratory activation energy is reduced by the H atom, but the adsorption location and migration course of the O atom remain same. When O atoms infiltrate and diffuse through crystals of Al, this phenomenon is more noticeable.

Aluminium oxidation includes O atom penetration and diffusion within the crystal of aluminium in addition to surface adsorption and migration processes. The tetrahedral interstitial position, created by aluminium atoms of the surface and subsurface layers, was discovered to be the point where the O atom infiltrates the crystal of aluminium from the surface. This position was also the occupancy position in the crystal of aluminium model. The location and migratory path remain the same when the H atoms engage in the infiltration process, just like they do on the surface. The addition of H atoms was shown to lower the infiltration activation energy of O atoms by 49%, despite the fact that the activation energy of the infiltration process is larger than the migration on the surface of aluminium (Fig. 3).

It was discovered that the O atom entered the crystal of aluminium at the tetrahedral interstitial location, which is just under the surface atom of aluminium (top view). When the O atom enters the crystal of aluminium from the surface, an energy barrier must be overcome in order to “lift” the surface aluminium atom (Fig. 3a). The surface of aluminium layer spacing will rise from 2.34 Å to 2.45 Å as a result of the invading process. The gradual deep oxidation of aluminium may possibly be connected to the process’s high activation energy (1.52 eV).

However, atom H complicates the diffusion process, which may be divided into three stages (points I–III in Fig. 3). First, the H atom is adsorbed on top of the O atom at the Fcc location on the surface of aluminium, connecting it to the O atom. Because O–Al has a higher binding energy than O–H, the latter

dissociates on the surface of aluminium. Following the dissociation, the O atoms and H adsorbed at the Fcc and the closest Top positions, respectively (Fig. 3b). The link between H and Al induces charge transfer, which causes the atom aluminium to leave the surface, known as the “abstract” effect.^{52,53} This impact lowers the activation energy of the migratory process. The O atom then goes down into the crystal of aluminium, while atoms H move from the top to the Fcc location. In this stage, the links between O atoms and Al atoms between two surfaces must be disrupted in order for O atom to make new bonds with three atoms of Al in the sublayer. The presence and movement of H atoms dramatically minimize energy fluctuations during bond breaking, making it easier for O atom to be adsorbed on the surface of aluminium. Furthermore, the effect of H atoms causes O atom to penetrate the crystal of aluminium from the surface more easily.

In order to accurately understand the charge transfer between O atom and H atom on the (111) surface of aluminium and inside the crystal of aluminium, the Bader charge had been calculated, and the specific results are shown in Table 3. Where the Al_n (n in 1, 2, 3, 4, 5, 6) means the Al atom around the O atom or H atom.

Starting with the absorption of the O and the O–H group on the (111) surface of aluminium. At the Top position, the charge of the O atom increased by 1.22, while the charges at the Hcp and Fcc positions are both 1.60 (the charge at the Fcc position is slightly larger than that at the Hcp position). When the hydrogen atom enters, the charge transferred to the oxygen atom increases. However, the number of atoms at the Hcp and Fcc positions is still higher than that at the Top position. These results correspond exactly to the calculated adsorption energy.

3.2 Occupancy and migration processes within the crystal of aluminium

In crystal of aluminium, there were two solid solution positions: the octahedral (Oct) interstitial position and the tetrahedral (Tet) interstitial position. For O atom, the binding energy at the Oct interstitial position was much smaller than that at the Tet interstitial position, indicating that the Tet interstitial position is more stable. In general, the octahedral interstitial position has a larger space in face-centered cubic crystal. The radius of O atom is 0.74 Å, whereas the radius of the octahedral and tetrahedral interstitial spheres of the lattice of aluminium were found to be 0.146 a and 0.080 a , respectively, where a is the lattice constant of the crystal of aluminium.²⁹ Thus, O atoms should easily occupy and remain stable in the octahedral interstitial positions. This could be caused by the formation of solid solution which is related to the electronegativity difference and bonding type between the atoms. Fig. 4 shows that there is a significant charge transfer between the Al atoms and O atoms. The density of states results (Fig. 4) show that the 2p orbital of O atoms resonates with the 3s orbital of the Al atoms, indicating the formation of a chemical bond. The differential charge density shows that at the Oct interstitial position, the O atom obtains electrons to form ionic bonds. However, at the Tet interstitial position, the O atom forms an ionic bond and

Table 3 The charge of Al, O, and H atoms, and their charge changes relative to their own valence electrons (negative numbers in the labels of changes in charge indicate how much charge an atom loses, and positive values indicate how much charge an atom receives)

	Atom	Charge (q/e)	Changes in charge (q/e)	Atom	Charge (q/e)	Changes in charge (q/e)
O-Fcc	Al1	2.45	-0.55	Al	2.453	-0.55
	Al2	2.45	-0.55	O	7.60	+1.60
O-Hcp	Al1	2.48	-0.52	Al3	2.47	-0.53
	Al2	2.48	-0.52	O	7.60	+1.60
O-Top	Al	1.90	-1.10	O	7.22	+1.22
OH-Fcc	Al1	2.66	-0.34	O	7.65	+1.65
	Al2	2.66	-0.34	H	0.34	-0.66
	Al3	2.66	-0.34			
OH-Hcp	Al1	2.65	-0.35	O	7.61	+1.61
	Al2	2.65	-0.35	H	0.40	-0.60
	Al3	2.65	-0.35			
OH-Top	Al	2.05	-0.95	O	7.49	+1.49
				H	0.35	-0.65
O-Tet	Al1	2.55	-0.45	Al4	2.55	-0.45
	Al2	2.55	-0.45	O	7.81	+1.81
	Al3	2.55	-0.45			
O-Oct	Al1	2.61	-0.39	Al5	2.61	-0.39
	Al2	2.61	-0.39	Al6	2.61	-0.39
	Al3	2.61	-0.39	O	8.13	+2.13
	Al4	2.61	-0.39			
OH-Tet	Al1	2.50	-0.50	Al4	2.68	-0.32
	Al2	2.50	-0.50	O	7.82	+1.82
	Al3	2.50	-0.50			
	Al4	2.77	-0.23	Al	2.76	-0.24
	Al5	2.77	-0.23	H	2.13	+0.13
	Al6	2.77	-0.23			

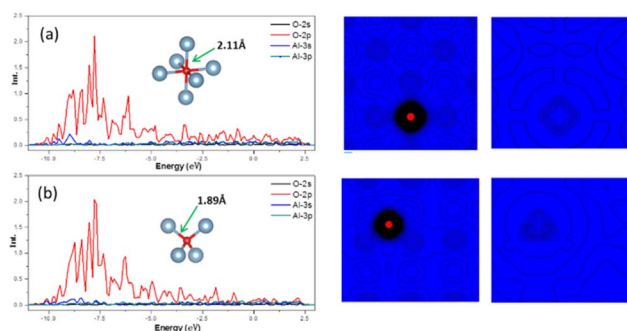


Fig. 4 Electronic structure at the Oct and Tet positions. Density of states, charge density, and differential charge density at (a) the Oct position in the Al (001) surface and (b) the Tet position in the Al (101).

contributes part of the electrons to form covalent bonds. The O–Al bond length at the Tet interstitial position is closer to that in alumina (there are two bond lengths between O atoms and Al inside alumina: 1.89 Å and 1.93 Å).^{54,55} This indicates that chemical bonds which are similar to those in the compound can also be formed in a solid solution system. This system is formed between elements with a large difference in electronegativity when the solubility is insufficient to form a compound. This phenomenon was confirmed in other interstitial solid solution systems.^{56–59}

As shown in Table 3, in the case of the occupation of the O atom and O–H group within the crystal of aluminium, the

charge transferred to the O atom at the Tet position is much lower than that at the Oct position. These results suggest the same outcome as the binding energy calculation, indicating that the occupation of the O atom at the Tet position is more stable. When it comes to the O–H group, the result shows that the charge transferred to the O atom is nearly the same as that of the O atom at the Tet position. Here, the Al atom has been divided into two parts. One part is a tetrahedron centered on oxygen atoms, and the other is a tetrahedron centered on hydrogen. And the charge transferred to the O atom is slightly larger when there is an H atom present compared to when there

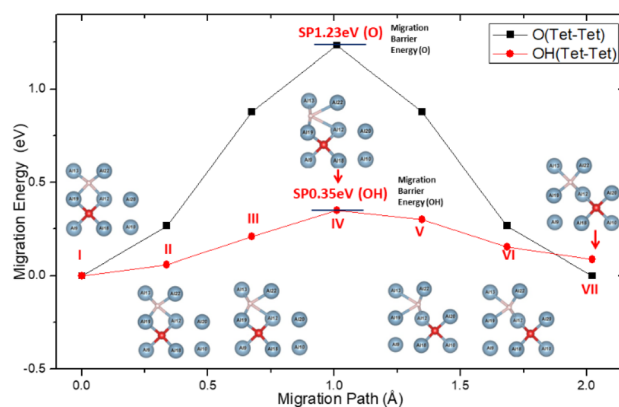


Fig. 5 Migration path and activation energy of O atom and O–H group within the crystal of aluminium.

is no H atom. The presence of an H atom indicates that the occupation of the O atom becomes more unstable, making migration easier.

Inside Al crystals, the O atom occupies the tetrahedral interstitial positions and the migration of O between the interstitial positions of the stable tetrahedron becomes more difficult. For which the migration activation energy is as high as 1.23 eV, as shown in Fig. 5. This is consistent with the results reported in the literature.⁶⁰

When H atoms are introduced into the solid solution system of O in the crystal of aluminum, H atoms will occupy the interstitial positions of the tetrahedron of the lattice and form a diagonal space relationship with the interstitial O atoms in the nearest neighbour space according to the formation energy result.

The presence of H atoms aggravates the distortion of the Al lattice around the O atoms, making it easier for the O atoms to migrate between the interstitial positions of the tetrahedron. The activation energy on the migration path was greatly reduced from the original 1.23 eV to 0.35 eV, which is the energy barrier for the migration of O atoms on the surface of aluminum. This indicates that the migration and diffusion processes of O atoms in the crystals of aluminum are easier than when there are H atoms in the crystal.

In addition, the easier migrating of atoms will not cause any accumulation to hinder further oxidation on the surface. This can be attributed to the coupling action of H atoms and O in the migration process, as shown in the inserts in Fig. 5. Until it reached the SP, the migration of O atom was found to drive the adjustment of the surrounding Al atoms. Although the H atoms also follow the same diffusion path, the O–H spacing gradually increases (points I–III on Fig. 5). At the SP, the system energy was the highest along the migration path, and the distance between the H atom and the Al atom (No. 12 and No. 22) was maximized (point IV on Fig. 5). After the SP, the system energy began to decrease, and the H–Al distance gradually recovered (points V–VII on Fig. 5). This may be attributed to the spatial occlusion, because the process of H–Al distance change is not a sudden change. The phenomenon of following of H atom and adjustment of the surrounding Al atoms can be attributed to the polarization of the local Al atoms under the influence of the H added O atoms. Furthermore, the competition between H, Al, and O slows the energy fluctuation during migration.

The O atom occupies the Tet interstitial position in Al crystals stably and it migrates with difficulty due to the higher activation energy required. When the H atom is nearby, the H atom will occupy the interstitial position of the tetrahedron of the crystal lattice and form a diagonal relationship with the O atom in the nearest neighbour space. As the diffusion of the H atom follows that of the O atom and due to the adjustment of surrounding Al atoms, the energy barrier is reduced. Thus, the internal migration of O becomes comparable to the surface migration.

Based on the adsorption and migration behaviour on the (111) surface of Al, pass through the surface to crystal (migration only) and inside the crystal, we can guess that it is still difficult for O atoms to enter the crystal of aluminum to achieve further oxidation when anions reach the M/O surface, which is

due to the O atoms very easily bonding with Al atoms and migrating quickly on the surface of aluminum to form a dense and stable oxide layer, even if there are vacancies after Al cations diffuse.

Result of the O–H effect after the introduction of H atoms, the behaviour of O atoms on the surface of aluminum and inside the crystal of aluminum is affected. On the one hand, the “abstract” effect of H atoms significantly reduces the energy barrier for O atoms to penetrate into the crystal from the surface of aluminum; on the other hand, the following and coordinating role of H atoms significantly lower the energy barrier of void O atoms migration inside the crystal of aluminum. Thus, H atoms have an important influence on the oxidation of Al. According to the calculations in this paper, the growth rate of the oxide layer depends on the concentration of H atoms under the situation of without considering the effect of electric field and the migration of cations (Al^{3+}). For the resource of H atoms, it can be considered that if H atoms are from the dissociation of OH ions at the M/O interface, then the growth rate of the oxide layer depends on the pH value of the electrolyte. It is not difficult to understand that in the electrolyte close to neutral, high OH concentration leads to the rapid growth of oxide layer and finally forms dense barrier oxide. However, in the anodic oxidation of acidic solution, the concentration of H atoms at the M/O interface is limited by a smaller number of hydroxide ions, which leads to the balance of oxidation and dissolution rates and finally realized a porous oxide.

4. Conclusions

To elucidate the behaviour of the ions in the anodic reaction during the anodizing of aluminium, the first-principles calculations were used to study the influence of H atoms on the surface behaviour of O atoms on the (111) surface of Al and its infiltration behaviour into the crystal phase. The main conclusions are as follows:

(1) In the process of Al oxidation, the “abstract” effect of H atoms greatly reduces the energy barrier for O entering the crystal of aluminum, from 1.52 eV to 0.78 eV, which is from the dissociation of O–H atomic groups.

(2) The introduction of H atom also effects the diffusion of O atom in the crystal of aluminum, which can significantly reduce the activation energy for O atom to migrate between the tetrahedral interstitial positions, from 1.23 eV to 0.34 eV. This is due to the following and coordinating effect of H atom on O atom during the migration process.

It is helpful for us to understand the anodic oxidation process and ion transport process.

Conflicts of interest

There are no conflicts to declare.

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